



03500.013630.

2815

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAAKI IWANE ET AL.) Examiner: Mr. Jose R. Diaz
Application No.: 09/346,678) Group Art Unit: 2815
Filed: July 2, 1999)
For: CRYSTAL GROWTH PROCESS,)
SEMICONDUCTOR DEVICE,)
AND ITS PRODUCTION)
PROCESS) May 3, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated February 3, 2004, please amend the
above-identified application as follows.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

May 3, 2004
(Date of Deposit)

John A. Krause
(Name of Attorney for Applicant)


Signature

May 3, 2004
Date of Signature